

Form PTO-1449 (modified)		Atty. Docket No.: ESSR:090US	Serial No.: 10/523,951
List of Patents and Publications for Applicant's INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)		Applicant: Karin SCHERER <i>et al.</i>	
		Filing Date: February 8, 2005	Group: 1794
U.S. Patent Documents <i>See Page 1</i>	Foreign Patent Documents <i>See Page 1</i>	Other Art <i>See Page 1</i>	

U.S. Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Name	Class	Sub Class	Filing Date of App.

Foreign Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Country	Language

Other Art (Including Author, Title, Date Pertinent Pages, Etc.)

Exam. Init.	Ref. Des.	Citation
/JL/	C2	Decker <i>et al.</i> , "Thin Film Magnetic Structure with Diffusion Barrier Layer," <i>IBM Technical Bulletin</i> , 22:2865, 1979.

60064944.1

EXAMINER: /Jonathan Langman/

DATE CONSIDERED: 01/07/2008

EXAMINER: INITIAL IF REFERENCE CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED. INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.

INFORMATION DISCLOSURE STATEMENT — PTO-1449 (MODIFIED)